RECEIVED CENTRAL FAX CENTER

OCT 18 2005

Inventor:

H. Montgomery Manning

Title:

Methods of Forming Capacitor Devices

Assignee: Micron Technology, Inc.

Serial No.: 10/733.181

Filed:

December 10, 2003

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56 Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art are attached. No admission is made regarding whether the listed references are prior art.

This Supplemental Information Disclosure Statement is being filed before the mailing of a first Office Action on the merits. Therefore, no fee is believed to be required. However, in the event that a fee is required for filing this Supplemental Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.

Citation of these references is respectfully requested.

Respectfully submitted,

David G. Latwesen, Ph.D.

Reg. No. 38,533

Wells St. John P.S.

F			-1-1-1		(T	~ <u>-</u>		Sheet 1 of 1
Form PT	ATTY. DOCKET NO. MI22-2295			SERIAL NO. 10/733,181						
U.S. DEI PATENT	APPLICANT Micron Technology, Inc.									
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					FILING DATE December 10, 2003			GROUP 2812		
U.S. PATENT DOCUMENTS										
Examiner Initial		Document Number	Date	Name		Class	Subclass		Filing Date If Appropriate	
	AA	2001/0012223	08/01	Kohyama						
	AB	2002/0030221	03/02	Sandhu et al.						
	AC	2002/0098654	07/02	Durcan et al.						
	AD	2002/0153614	10/02	Ema et al.						
	AE	2003/0178684	09/03	Nakamura						
	AF				-					
	AG									
	AH									
	ΙA				_					
FOREIGN PATENT DOCUMENTS										
	l	D		-		- T				
		Document Number	Date	Country		Class	Sub- class		Transla	ition
			<u> </u>					_	Yes	No
	AJ	2004/ 027898	08/04	PCT Search Report				_		
	AK	2004/ 040252	12/04	PCT Search Report				\perp		
	AL		<u> </u>							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)										
	AM	Kim, D.H. et al., "A Mechanically Enhanced Storage Node for Virtually Unlimited Height (MESH)								
		Capacitor Aiming at Sub 70nm DRAMs", IEEE Jan. 2004, pp. 69-72.								
EXAMINER		DATE CONSIDERED								
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.										